

JPV



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

Docket No: Q81015

Shuho MOTOMURA

Appln. No.: 10/820,752

Group Art Unit: 1762

Confirmation No.: 8798

Examiner: Katherine A. Bareford

Filed: April 9, 2004

For: SUBSTRATE PROCESSING SYSTEM, COATING APPARATUS, AND COATING METHOD

SUPPLEMENTAL RESPONSE UNDER 37 C.F.R. § 1.114(c)

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the RCE filed March 19, 2007, please consider the supplemental remarks made on the accompanying pages.

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